

Fig. 2

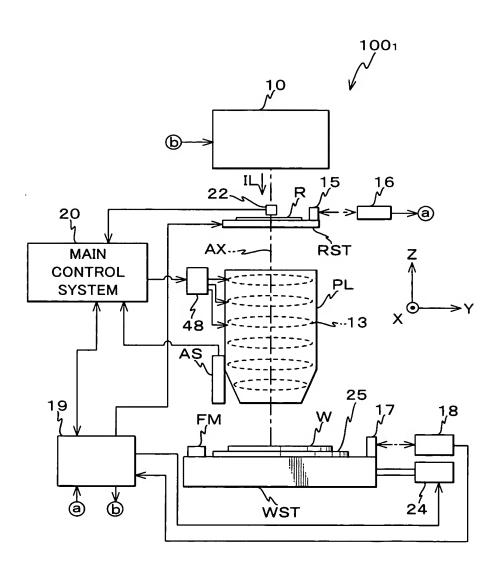
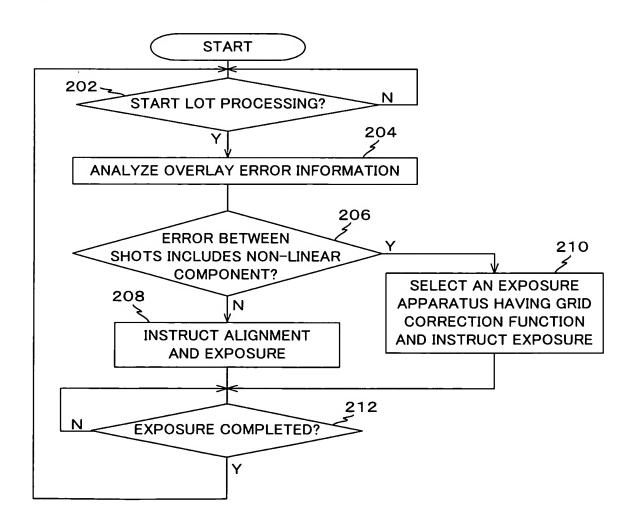


Fig. 3

PROCESS NAME n	Mn	MAP STORING REGION
А	1	
. В	1	
С	1	

Fig. 4



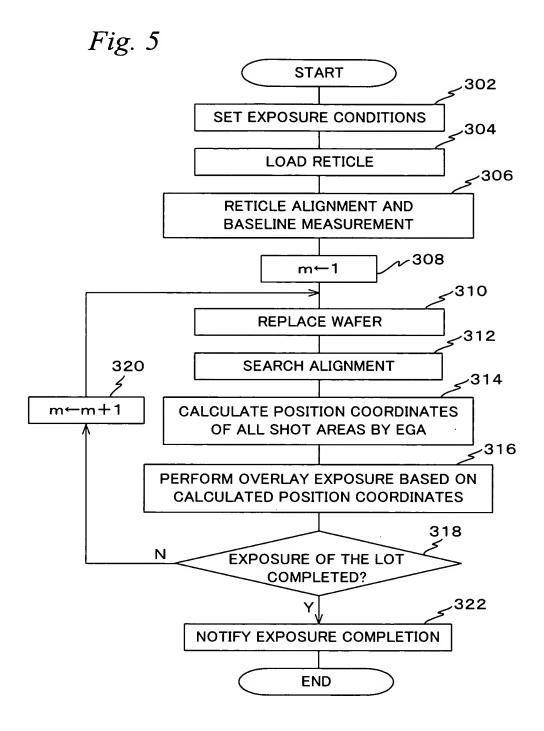
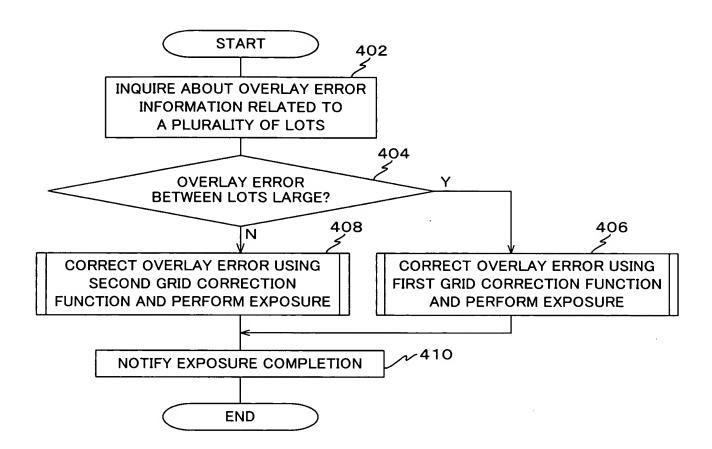
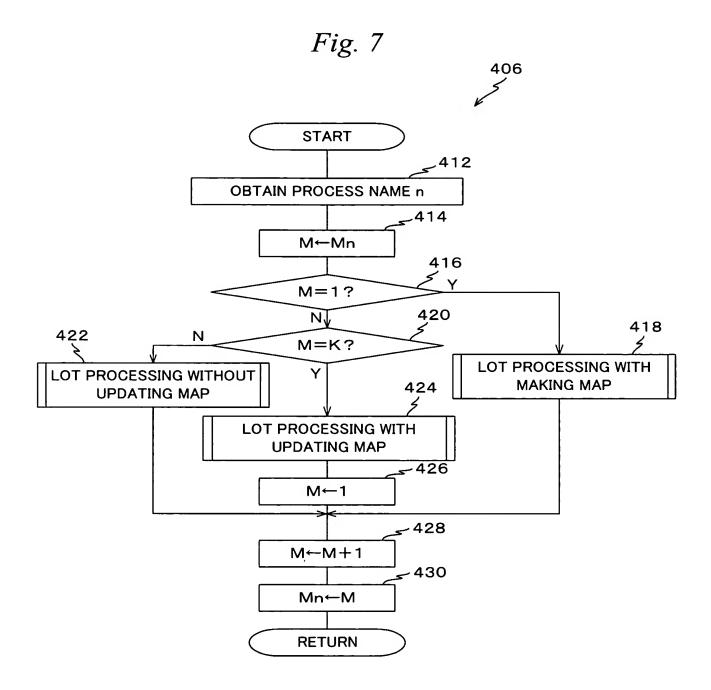
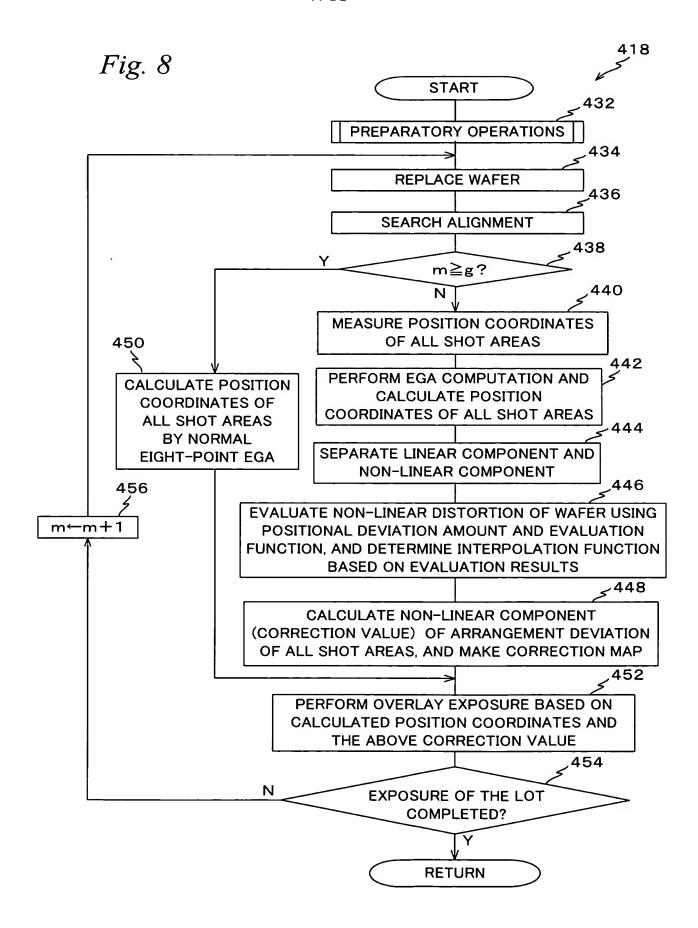


Fig. 6







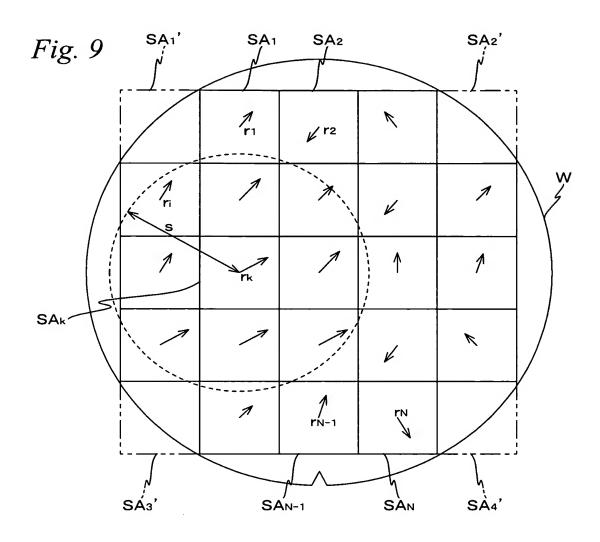
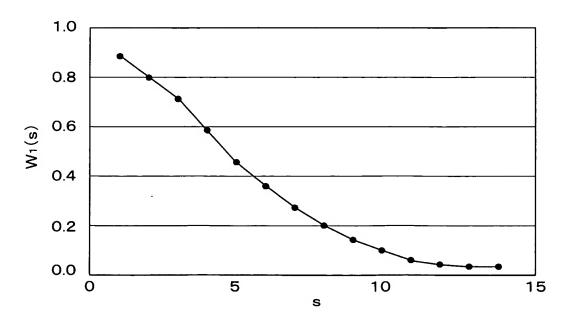
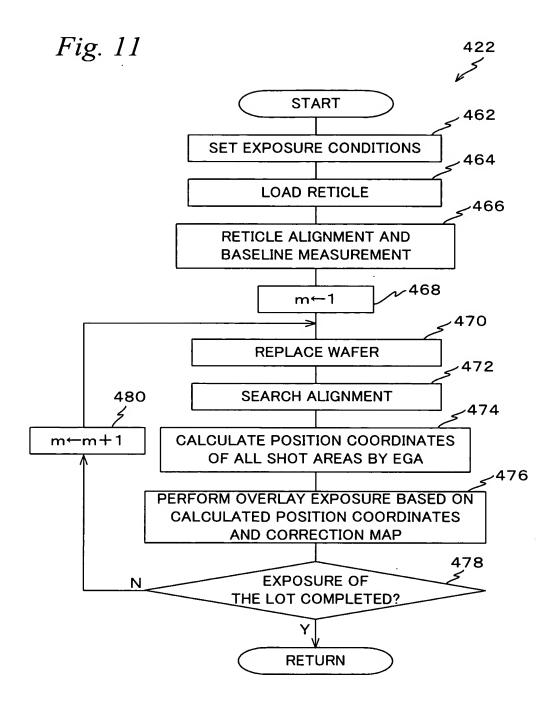


Fig. 10





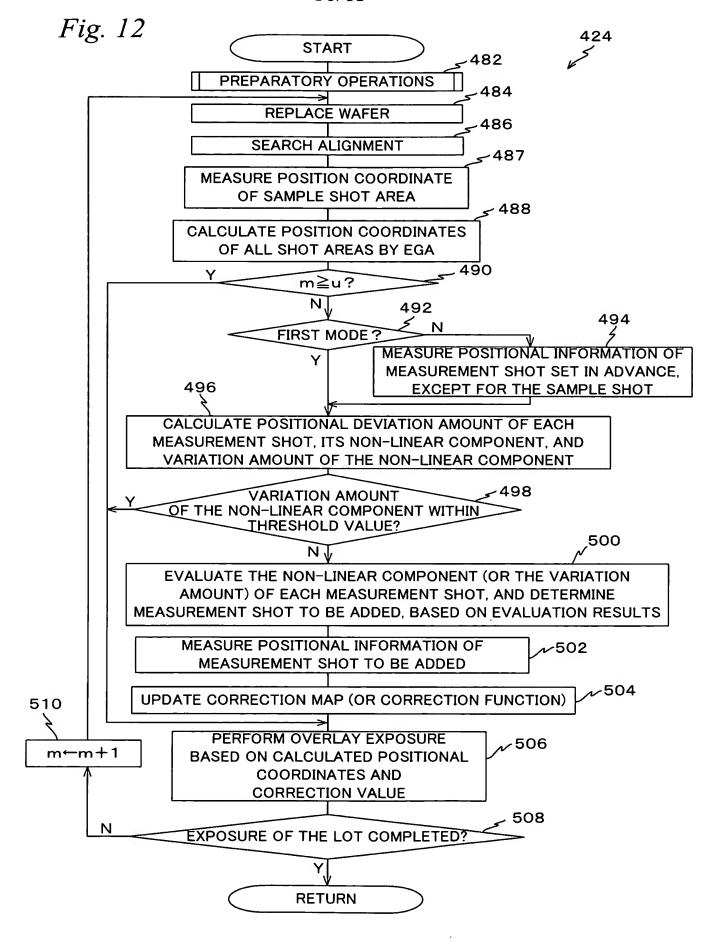


Fig. 13

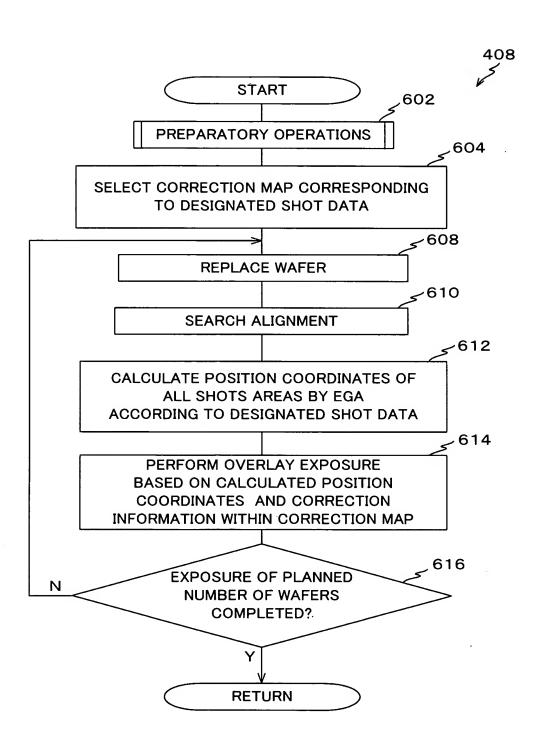


Fig. 14

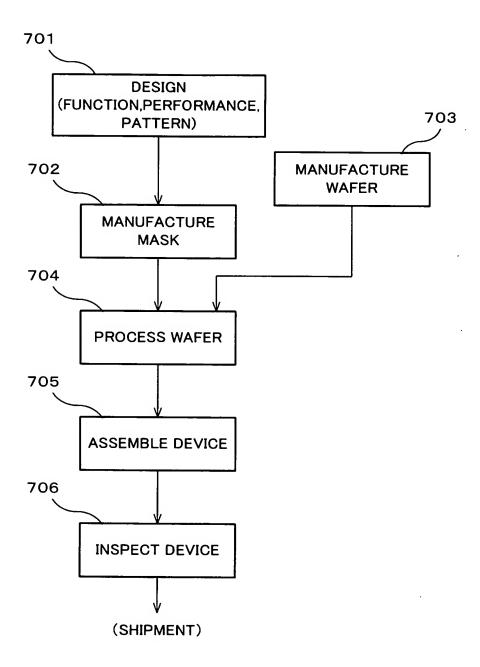


Fig. 15 714 ION IMPLANTATION 713 711 712 ELECTRODE FORMATION CVD PROCESS **OXIDATION** PRE-PROCESS 715 RESIST FORMATION 716 **EXPOSURE POST-PROCESS** 717 **DEVELOPMENT** 718 **ETCHING** 719 RESIST **REMOVAL**